# MICROPLASMA NOISE – COEFFICIENTS OF GENERATION AND RECOMBINATION

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### ABSTRACT

The occurence of microplasma regions in PN junctions is attributed to crystal lattice imperfections. As a rule, these regions feature lower strong-field avalanche ionization breakdown voltages than other homogenous PN junction regions [1]. The existence of such regions may lead to local avalanche breakdowns occuring in reverse-biased PN junctions at certain voltage. These local avalanche breakdowns may exhibit as a current impulse noise. These impulses are usually represented by constant amplitude, random pulse width and pulse origin time points. The current impulse noise is dependent on voltage. When the reverse voltage on PN junction increases, frequency and width of impulses are also increasing. The microplasma bistable behaviour may be described with two-state stochastic process of generation-recombination type.

## **1. INTRODUCTION**

The article deals with a study of a diodes exhibiting two level current impulse noise. The diodes show an unstable behaviour only in the certain range of reverse voltages,

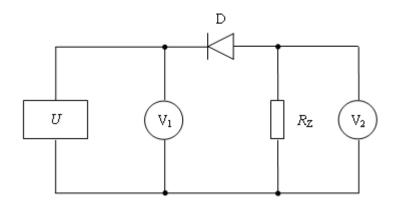


Fig. 1: The circuit for the microplasma noise measuring.

the voltage range depend on the junction defect region properties. When the reverse voltage increases within this interval the current impulse amplitude are showing a quasilinear growth, the average impulse width is increasing, whereas the average impulse separation is decreasing. This phenomenon is generally ascribed to local avalanche breakdowns originating in p-n junction defect regions called microplasma regions [1]. Fig. 1 shows the circuit for measuring current impulse noise, microplasma noise.

This behaviour can be described with a two-state stochastic process of generationrecombination type (G-R process) [4]. The coefficients generation g and recombination rcan be determined by several methods. The first of them is usage the distribution of the probability density  $f(\tau_0)$  of the impulse separation  $\tau_0$  and the probability density  $f(\tau_1)$  of the impulse width  $\tau_1$ . The next method, how find out the generation and recombination coefficients, depends on transition probabilities from state 0 to 1 and back from state 1 to 0 [1].

### 2. STATISTICAL CHARACTERISTICS OF MICROPLASMA NOISE

The characteristics of the impulse random process which arises consequence of the bistable nature of the microplasma conductivity, depend on the type of the load impedance connected in the circuit with diode [3]. The experiment shows that the microplasma bistable behaviour can be described with a two-state stochastic process of generation-recombination type, Markovian type. This type is typical for a voltage source. The resulting impulse process is non-Markovian if the diode power supply behaves as a current source. Two postulates describe the primary process:

- If the system is at a time *t* in the state 0 then the transition probability to the state 1 within the time interval  $(t, t + \Delta t)$  equals  $g \Delta t + o(\Delta t)$  [1].
- If the system is at a time t in the state 1 then the transition probability to the state 0 within the time interval  $(t, t + \Delta t)$  equals  $r \Delta t + o(\Delta t)$  [1].

The quantities g and r are the generation and recombination coefficients and  $o(\Delta t)$  is a transition probability to other states than neighbouring [1].

# 3. THE DISTRIBUTION OF PROBABILITY DENSITY $\tau_0$ , $\tau_1$ AND COEFFICIENTS gAND r DETERMINATION

It can be shown that the distribution of the probability density  $f(\tau_0)$  of the impulse separation  $\tau_0$  and the probability density  $f(\tau_1)$  of the impulse width  $\tau_1$  can be expressed as:

$$f \tau = g e^{-\tau}$$
(1)

$$f \tau = e^{-\tau}$$
(2)

These equations are only for a stationary random process [4]. A curve, which represent results of our experiment for  $f(\tau_0)$ , is in a good agreement with the proposed model, see fig. 2. The second curve for  $f(\tau_1)$  has some divergence, fig. 3. The grey line represents the mathematical model and the black one is from measuring. The numerical values for the generation and recombination coefficients are  $g = 7453 \text{ s}^{-1}$  and  $r = 6173 \text{ s}^{-1}$ .

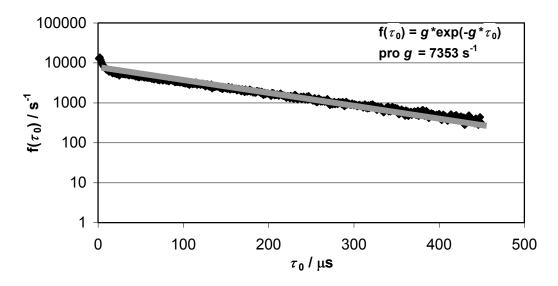


Fig. 2: The distribution of probability density  $\tau_0$ , the diode E3, U = 1534,6 V.

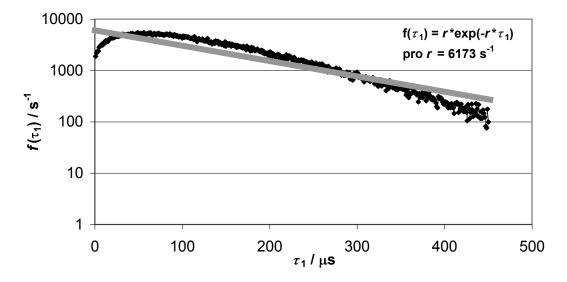


Fig. 3: The distribution of probability density  $\tau_1$ , the diode E3, U = 1534,6V.

# 4. CALCULATION OF THE COEFFICIENTS g AND r FROM THE TRANSITION PROBABILITY $P_{01}$ AND $P_{10}$

We can find the coefficients of generation and recombination by other way. The generation coefficient depends on the transition probability from the state 0 to 1 and the recombination coefficient depends on the transition probability from the state 1 to 0. When the system is in the state 0 and during the time period  $\Delta t$  goes to another one, in our case to the state 1, we call this transition probability as  $P_{01}$ . We compute  $P_{01}$  as a fraction between  $N_{01}$ ,

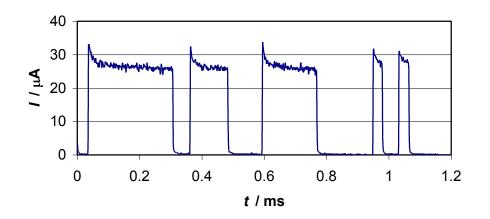


Fig. 4: Microplasma bistable behaviour current noise, the diode E3, U = 1534,6 V

a sum of every time period  $\Delta t$ , when the state is changed from 0 to 1 and  $N_0$ , a sum of the all time period  $\Delta t$ , when the system is in the state 0.

$$P_{01} = \frac{N_{01}}{N_0} \tag{3}$$

Then  $P_{10}$  will be the transition probability, when the system is in the state 1 and during the time period  $\Delta t$  goes to the state 0.

$$P_{10} = \frac{N_{10}}{N_1} \tag{4}$$

Here is  $N_{10}$  a sum of every time period  $\Delta t$ , when the state is changed from 1 to 0 and  $N_1$  is a sum of the all time period, when the system is in the state 1. There is an illustration of the course on the fig. 4, where we can see a part of the bistable current noise, microplasma noise. The coefficients of generation and recombination are obtained from the shown time behaviour or similar one. We can establish them from these equations:

$$g = \frac{P_{01}}{\Delta t} = {}^{\prime}298 \mathrm{s}^{-}$$
(5)

$$r = \frac{P_{10}}{\Delta t} = 5530 \,\mathrm{s}^{-} \tag{6}$$

### 5. CONCLUSION

It was measured one hundred courses of the bistable current noise, microplasma noise, time length 0.5 s for the same input voltage U = 1548,3 V. We established the distribution of the probability density  $\tau_0$ ,  $\tau_1$  from the data and found out that the course is exponential. Some difference was observed on the distribution of the probability density for  $\tau_1$ . The reason could be a change of temperature in the microplasma area during the local avalanche breakdowns. The verification will be an object for next research. The coefficients of generation and recombination were found out from the exponential distributions of the probability density  $\tau_0$  and  $\tau_1$ .

The second part was focused to the calculation the coefficients of generation and recombination from the transition probabilities  $P_{01}$  and  $P_{10}$ . The coefficients of generation are very similar in both of the methods, but the coefficients of the recombination have some differences, which could arise from the change of temperature in the microplasma area during the avalanche breakdowns.

# ACKNOWLEDGEMENTS

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